



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 25, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

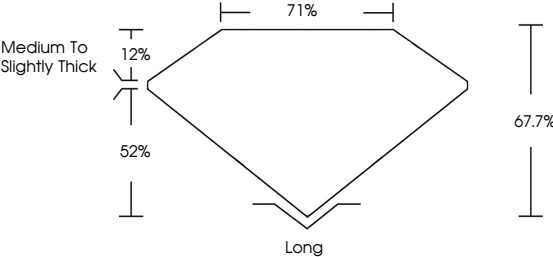
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG700575971

Report verification at [igi.org](https://www.igi.org)

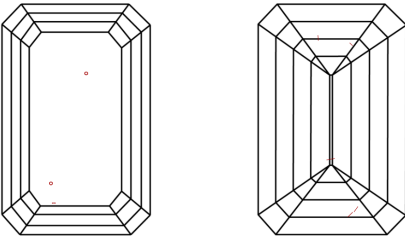
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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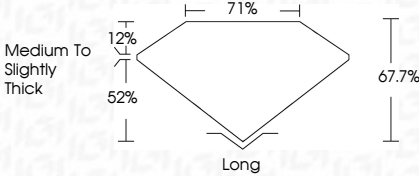
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PROPORTIONS



IGI



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April 25, 2025

IGI Report No LG700575971

EMERALD CUT

7.92 X 5.39 X 3.65 MM

Carat Weight

Color Grade

Clarity Grade

Table

Girdle

Medium to Slightly Thick

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.51 CARAT

D

VS 2

67.7%

71%

Long

VERY GOOD

EXCELLENT

NONE

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